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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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For : STRUCTURE MONITOR SYSTEM

MS PCT
Commissioner for Patents
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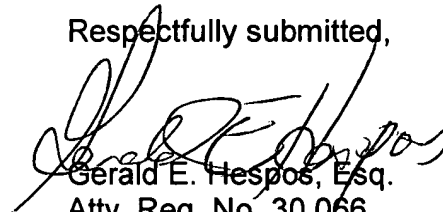
INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement includes a copy of Form PTO-1449 that identifies four Japanese references. Copies of all four references are attached as well. The relevancy of JP11-287650 is described in the first three pages of the subject application. The other three references were cited in the International Search Report, a copy of which is submitted concurrently with this application. The International Search Report identifies the perceived relevance of the three references.

The Examiner requested to consider these references during the examination and to make the references of records.

Respectfully submitted,



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Applicant(s) Kinzo Kishida et al.		
Filing Date Concurrently herewiht		Group Art Unit --

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

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FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		JP5-062081	1993	Japan				✓
		JP5-231956	1993	Japan				✓
		JP11-287650	1999	Japan				✓
		JP2002-340741	2002	Japan				✓

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.